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	APPLICANT(S): Barclay et al.	
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UNITED STATES PATENT DOCUMENTS

EXAM. INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FIL. DATE IF APPR
JSC	AA	6,239,231	05/29/2001	Fujishima et al.	525	337	
	AB	6,165,674	12/2000	Taylor et al.	430	270.1	
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Examiner: J Ch Date: 12/2005